

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q92105

Gyu-Chul YI, et al.

Appln. No.: 10/562,006

Group Art Unit: Unknown

Confirmation No.: Unknown

Examiner: Unknown

Filed: December 23, 2005

For:

P-N HETEROJUNCTION STRUCTURE OF ZINC OXIDE-BASED NANOROD AND

SEMICONDUCTOR THIN FILM, PREPARATION THEREOF, AND NANO-DEVICE

COMPRISING SAME

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the document which is listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of the listed document is submitted herewith.

1. S. Muthukumar et al., "Selective MOCVD Growth of ZnO Nanotips", IEEE

Transactions on Nanotechnology, Vol. 2, No. 1, March 2003, pp. 50-54.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action

INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: 10/526,006

March 20, 2006

on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after

filing a request for continued examination (RCE) under §1.114, and therefore, no Statement

under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

The submission of the listed document is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicant does not

waive any right to take any action that would be appropriate to antedate or otherwise remove any

listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account.

Respectfully submitted,

Registration No. 53,892

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WASHINGTON OFFICE

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Date: March 20, 2006

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Complete if Known

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STATEMEN'	Γ BY APPLICANT

INFO	RMATION 1	DISCLOSURE	Confirmation Number	Unknown	
STATEMENT BY APPLICANT		Filing Date	December 23, 2005		
(use as many sheets as necessary)		First Named Inventor	Gyu-Chul YI		
		Art Unit	Unknown		
		Examiner Name	Unknown		
Sheet	1	of 1	Attorney Docket Number	Q92105	

Application Number

	U.S. PATENT DOCUMENTS					
Examiner Cit Initials* No.	Cita	Document	Number	Publication Date		
	No.1	Number	Kind Code ² (if known)	MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
		US				
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FOREIGN PATENT DOCUMENTS							
Examiner Cite Foreign Patent Document	ent Publication Date	Name of Patentee or					
Initials*	No.1	Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
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	NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶	
		S. Muthukumar et al., "Selective MOCVD Growth of ZnO Nanotips", IEEE		
		Transactions on Nanotechnology, Vol. 2, No. 1, March 2003.		

Examiner Signature	Date Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.